



The First Result of the 28GHz Superconducting ECR Ion Source at KBSI

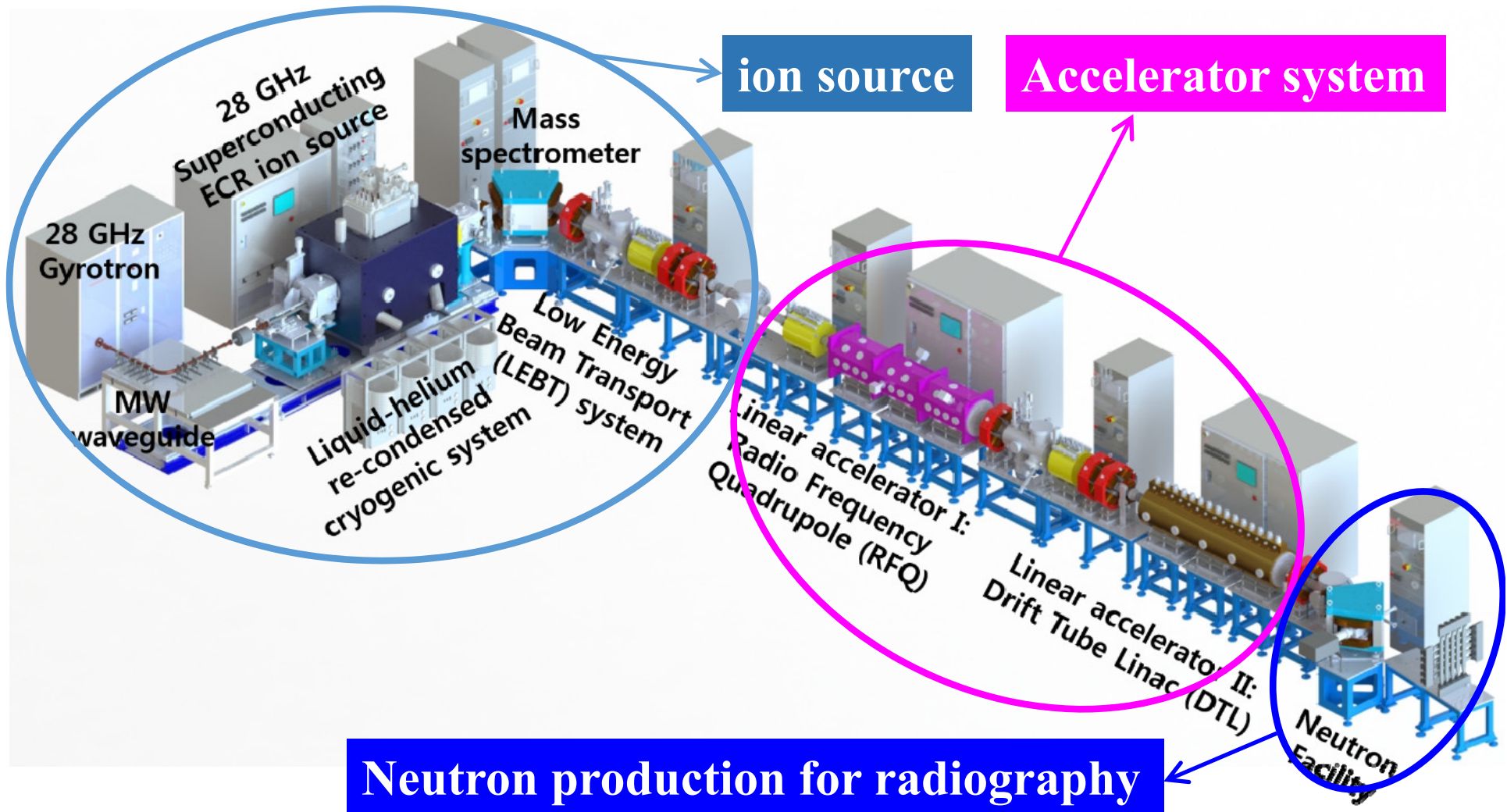
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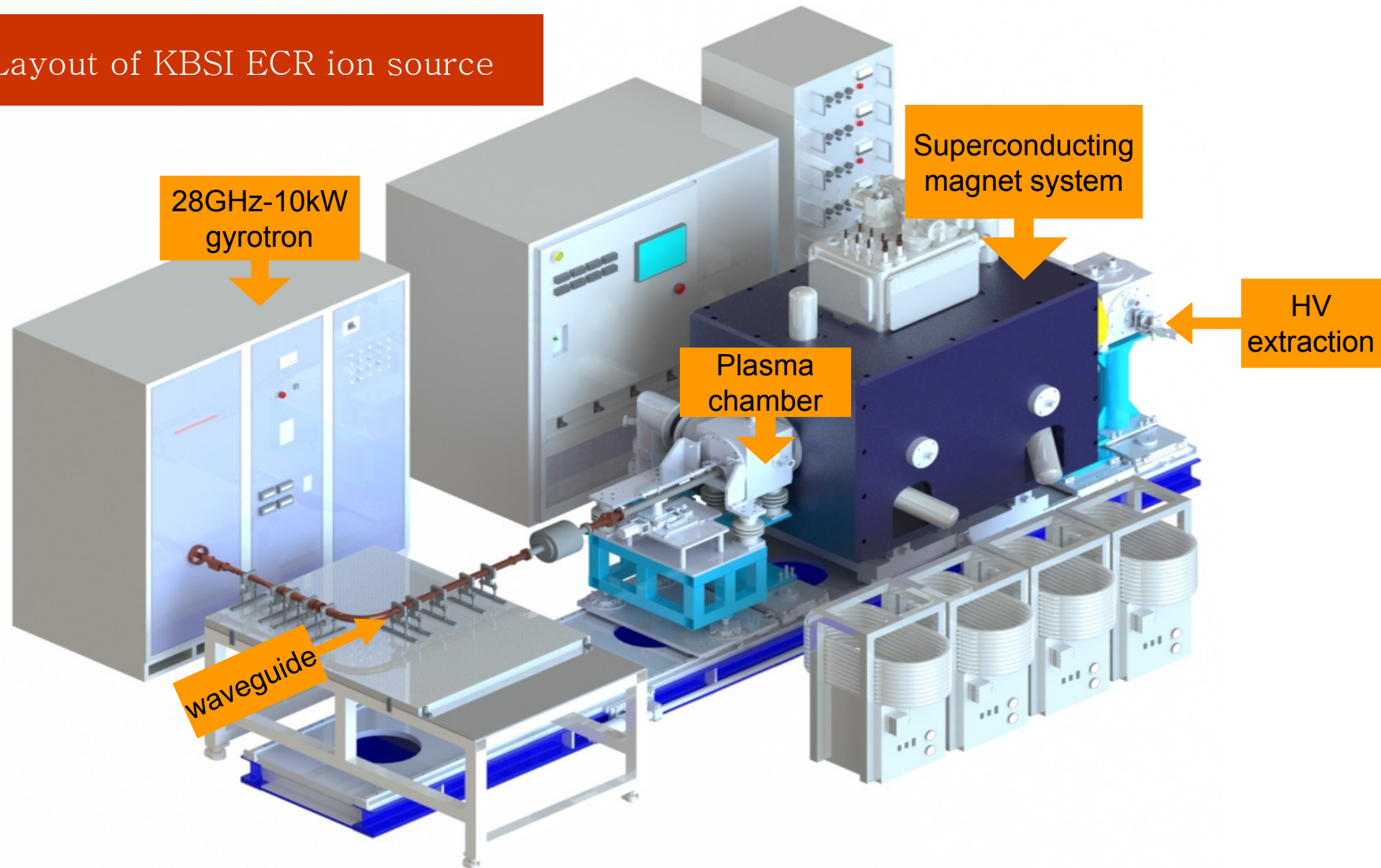
- » **KBSI 28GHz ECR Ion Source**
- » **X-ray and Ion beam Measurement system**
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- » **Conclusion & Future Plan**

KBSI Accelerator System for Neutron Facility

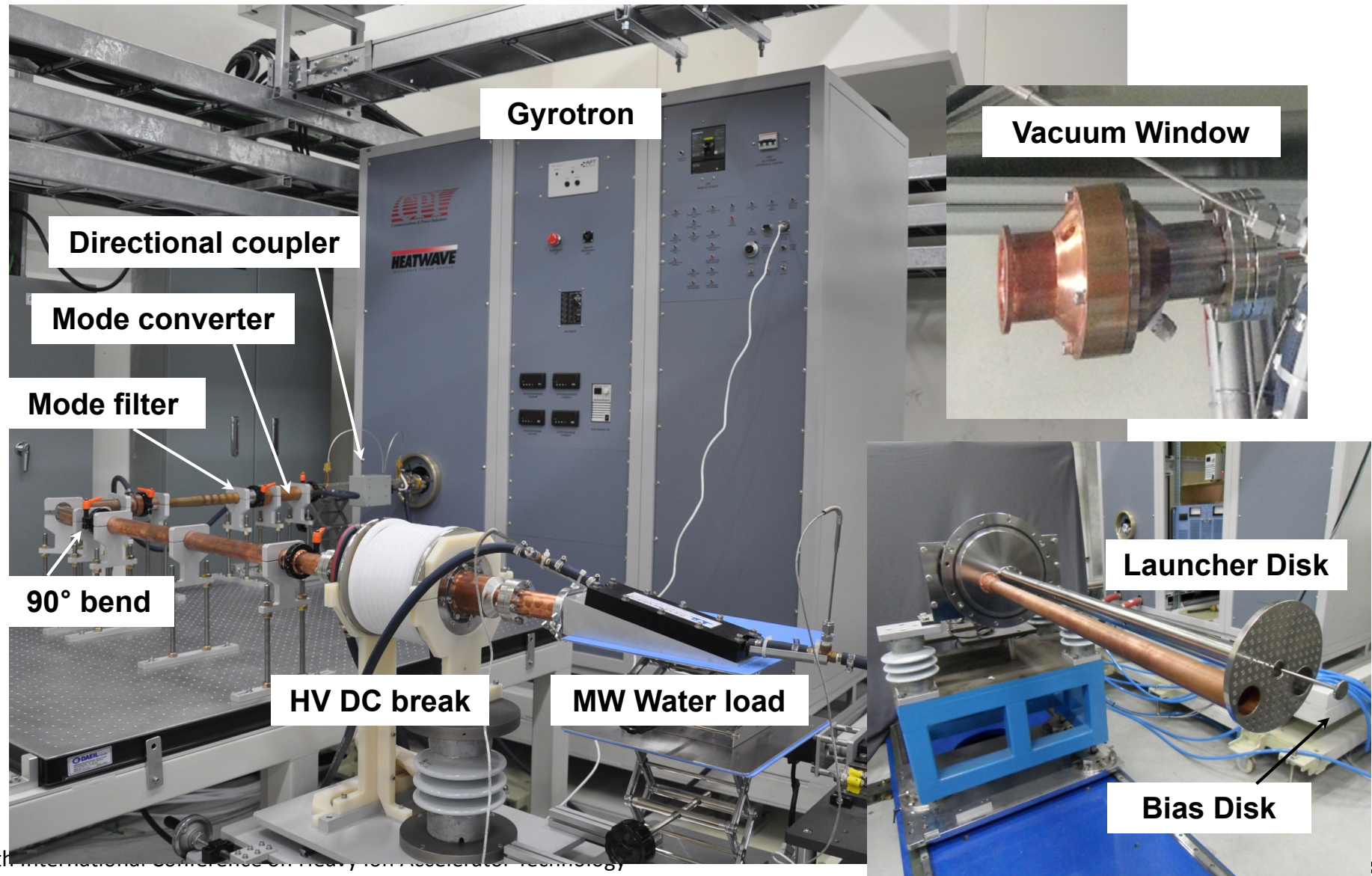


Configuration of KBSI 28 GHz ECR Ion Source

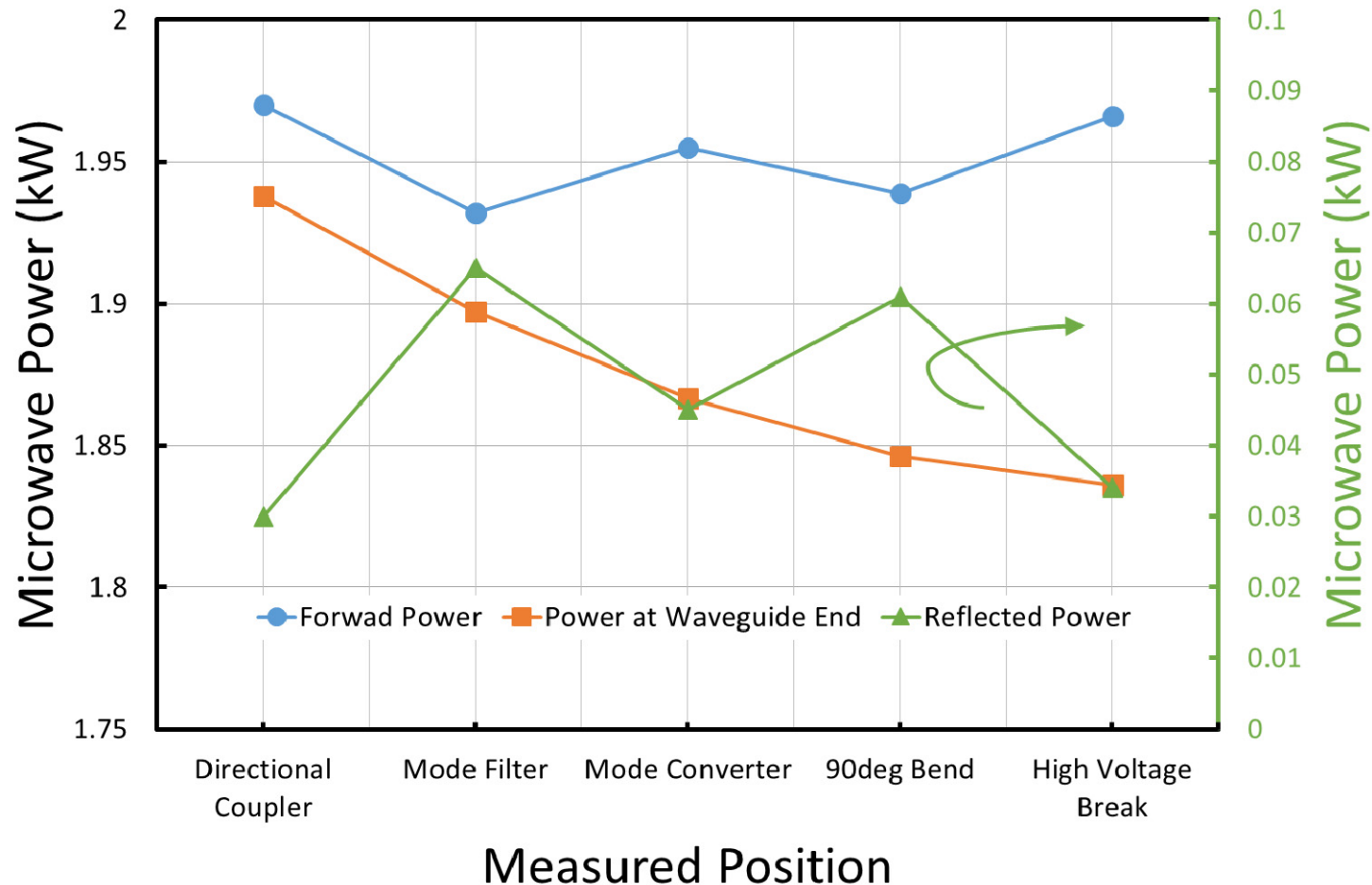
Layout of KBSI ECR ion source



28GHz Microwave System

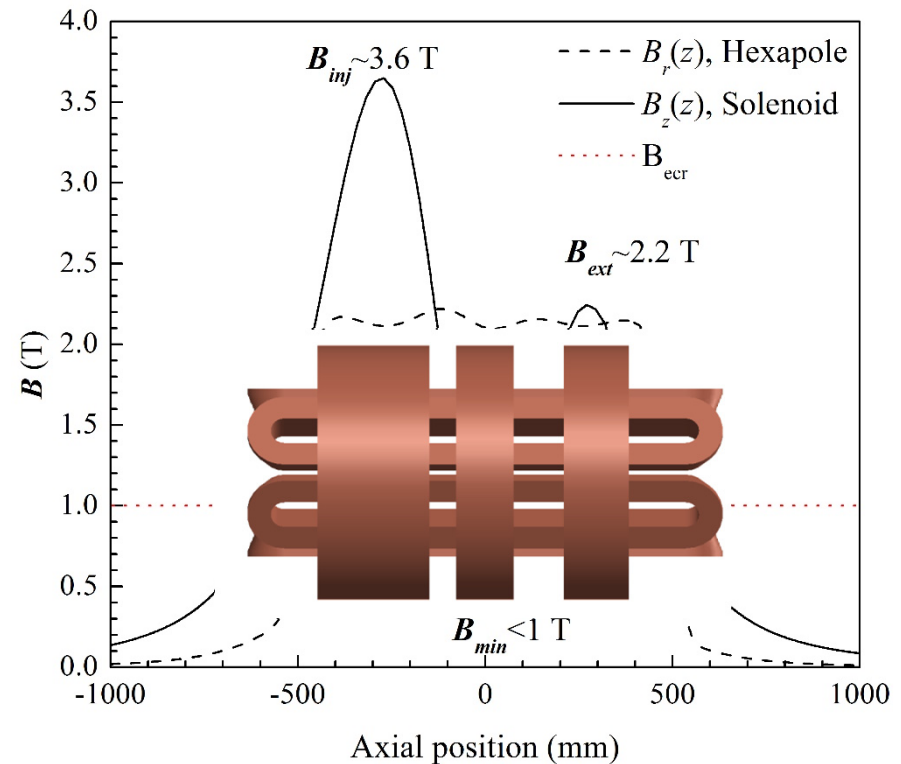
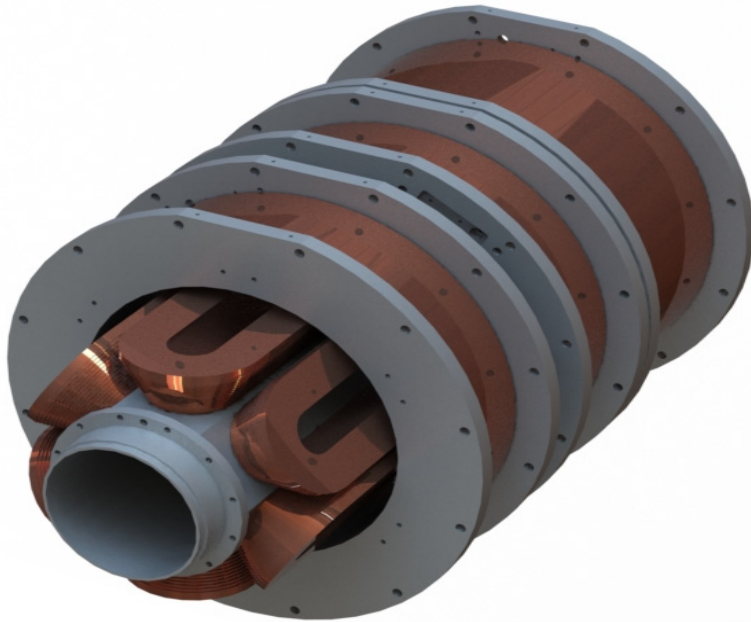


Microwave Power Transmission System



- The transmitted power to plasma chamber is above 92% at 2 kW

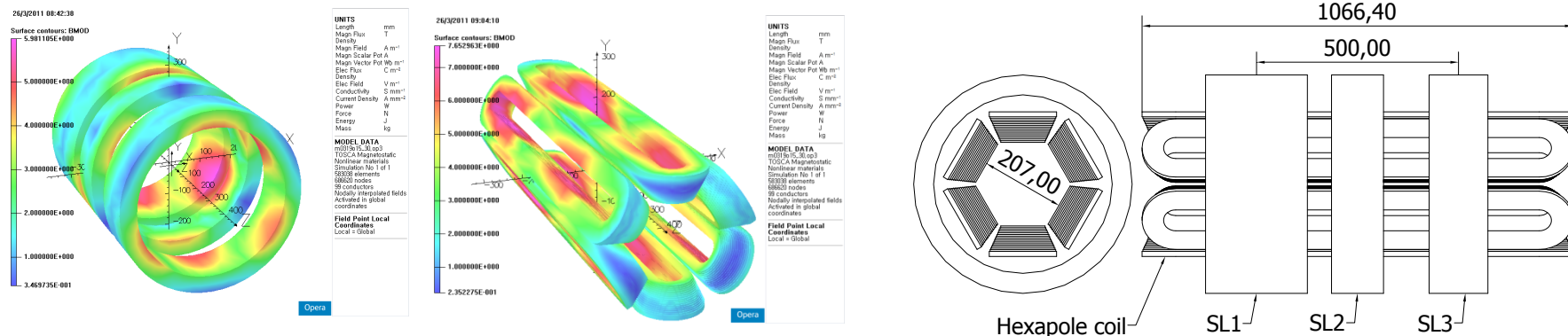
Superconducting magnet system: Design results



3 Solenoid + 1 hexapole magnet (6 step-type coils)

- The axial field: ~ 3.6 T at injection, ~ 2.2 T at extraction.
- The minimum axial field (variable): $0.4 \sim 0.8$ T.
- The radial design field on the plasma chamber wall: 2.1 T

Superconducting magnet system: Design results

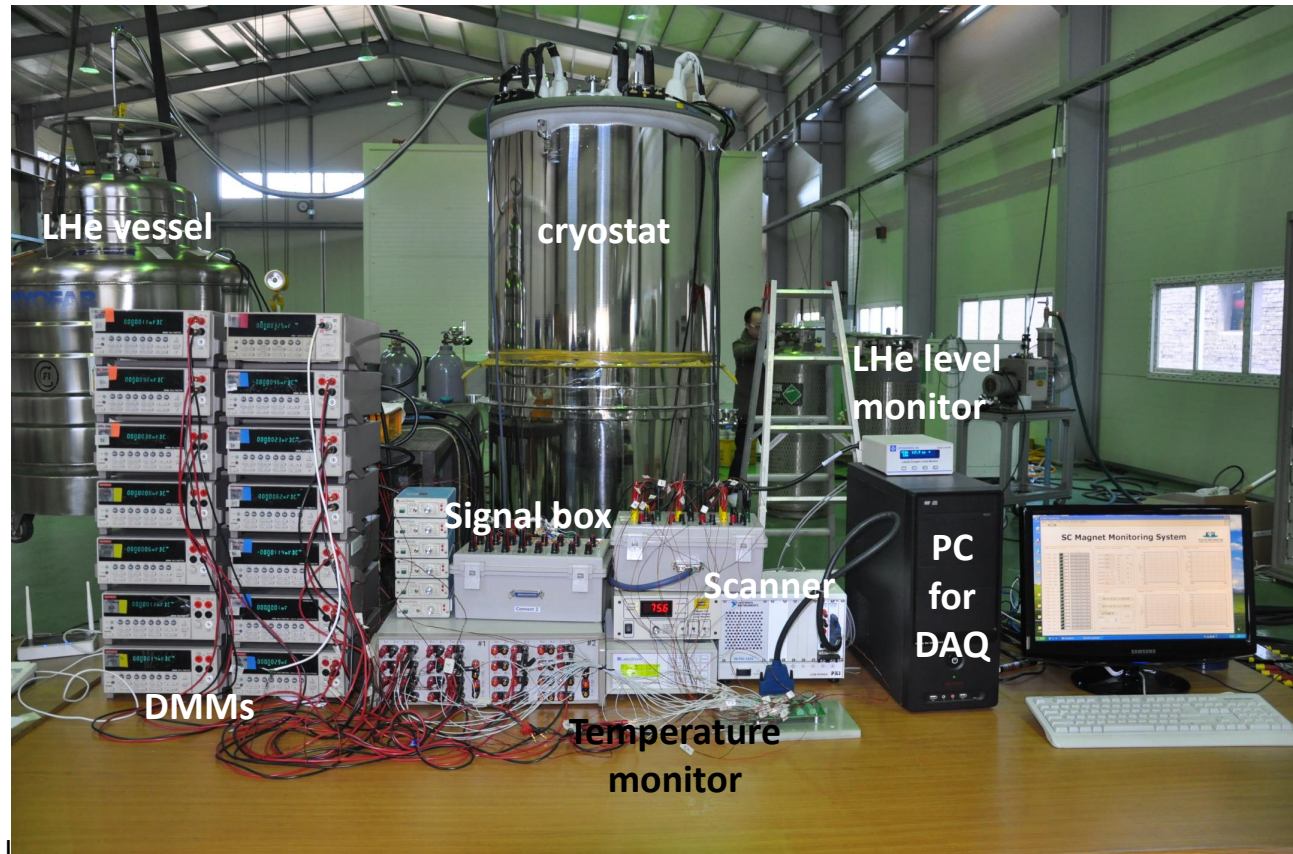


	SL1	SL2	SL3	Hexapole
Axial position of center (mm)	-250	+250	0	0
Inner diameter (mm)	442	442	442	207
Outer diameter (mm)	540.8	540.8	540.8	394.96
Depth (mm)	49.4	49.4	49.4	75.6
Width (mm)	252	128.8	145.6	53.2
Hexapole length (mm)	-	-	-	1066.4
Hexapole inner radius (mm)	-	-	-	30
Conductor size (mm)	0.95 x 1.4	0.95 x 1.4	0.95 x 1.4	0.95 x 1.4
Cu/NbTi ratio	4.9	4.9	4.9	2.32
Turns/coil	9360	4784	5408	2304
Wire lengths/coil (km)	14.5	7.4	8.4	4.9
Current (A)	197	198	197	263
B_{max} (T)	5.98	5.35	4.72	7.65
Inductance (H)	39	13.5	16.5	23

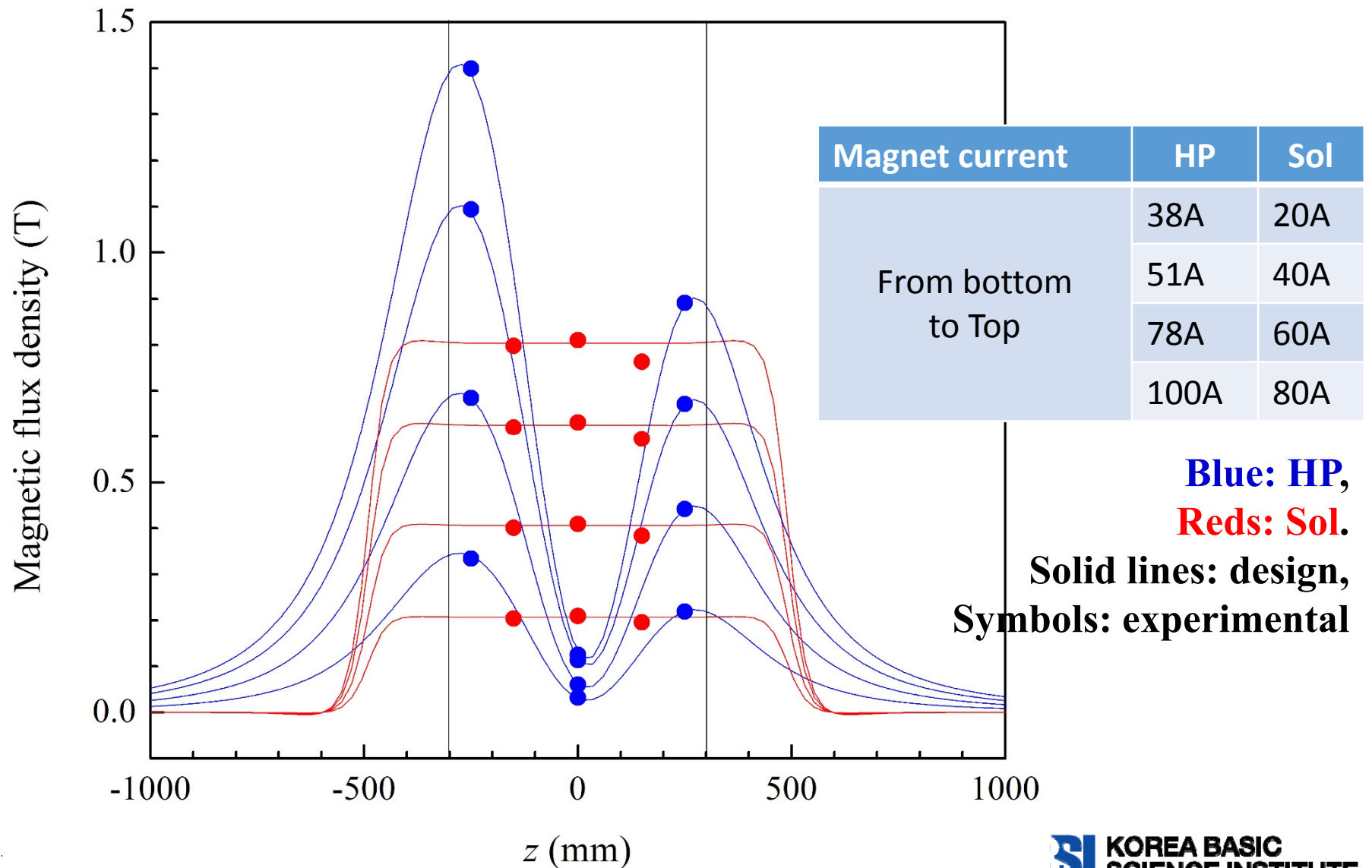
Initial performance test of superconducting magnet

Magnet test at open-type cryostat

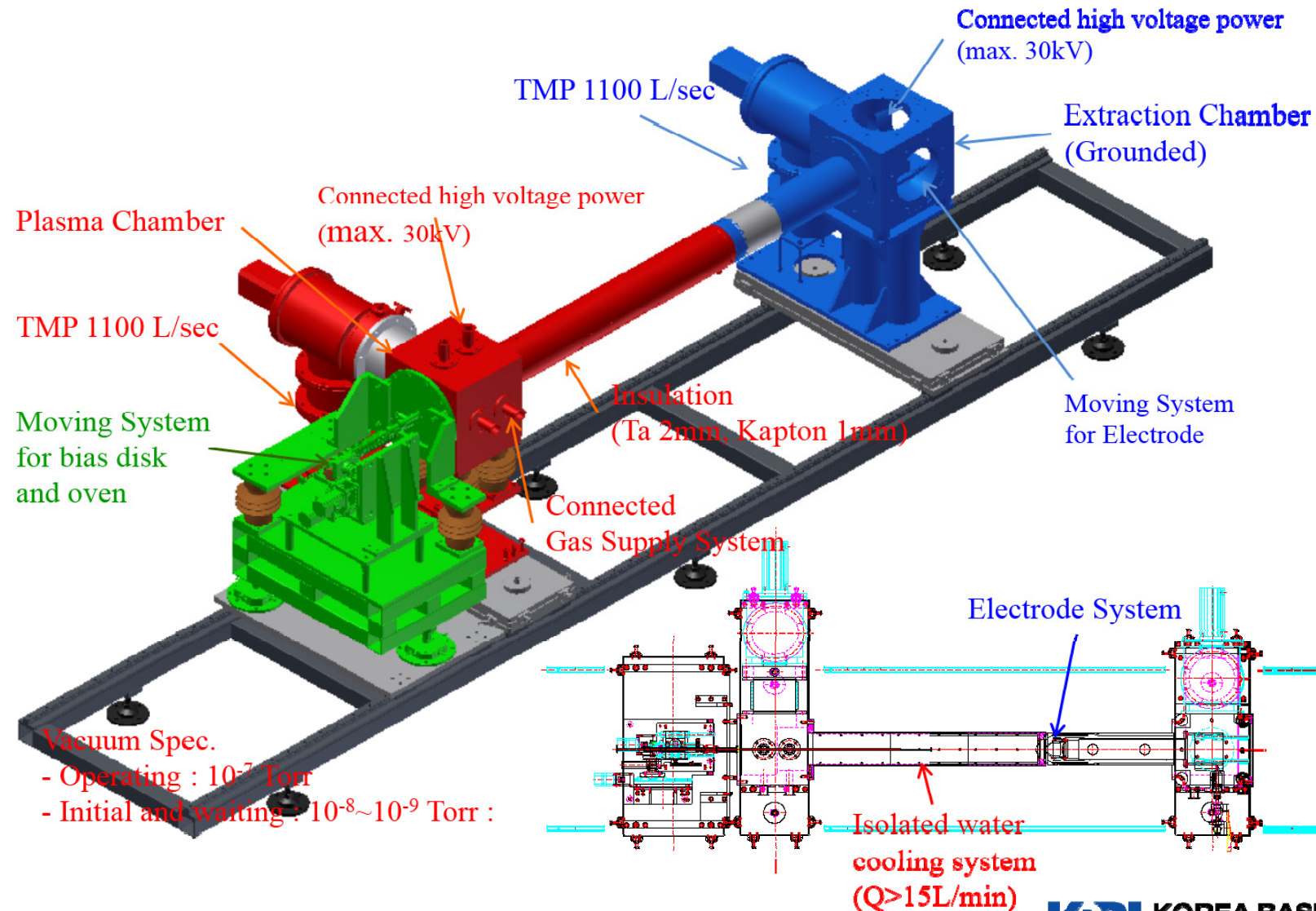
- Separate coil performance was checked before final assembly
- Vertical cryostat(open type) was prepared for convenient test
- Magnet status, temperature, magnetic field were observed



The comparison of magnet field between design and experimental values



Plasma Chamber & Extraction System

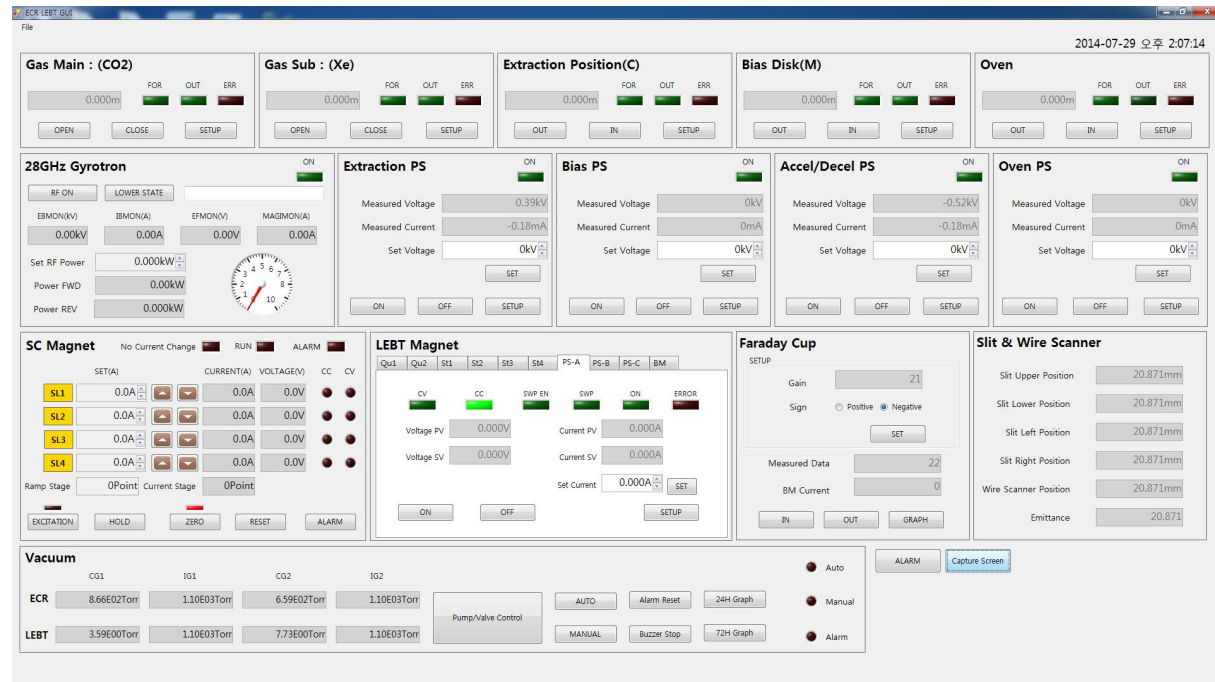


Remote control Program

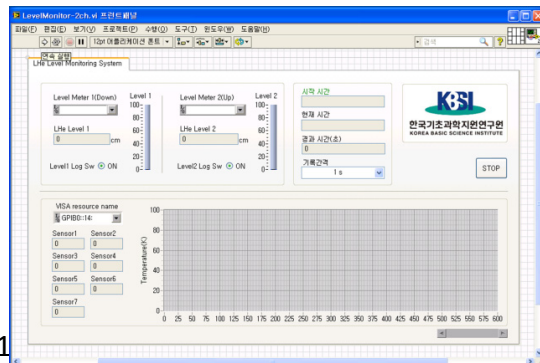
Control Cabinet



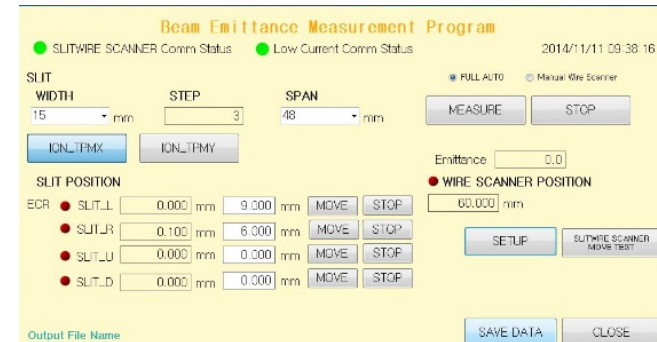
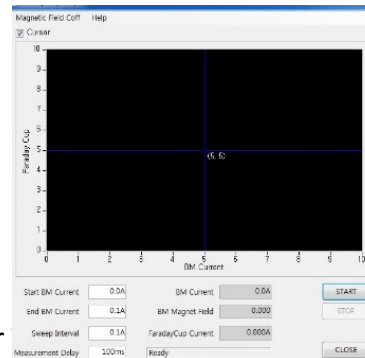
Main Control Program



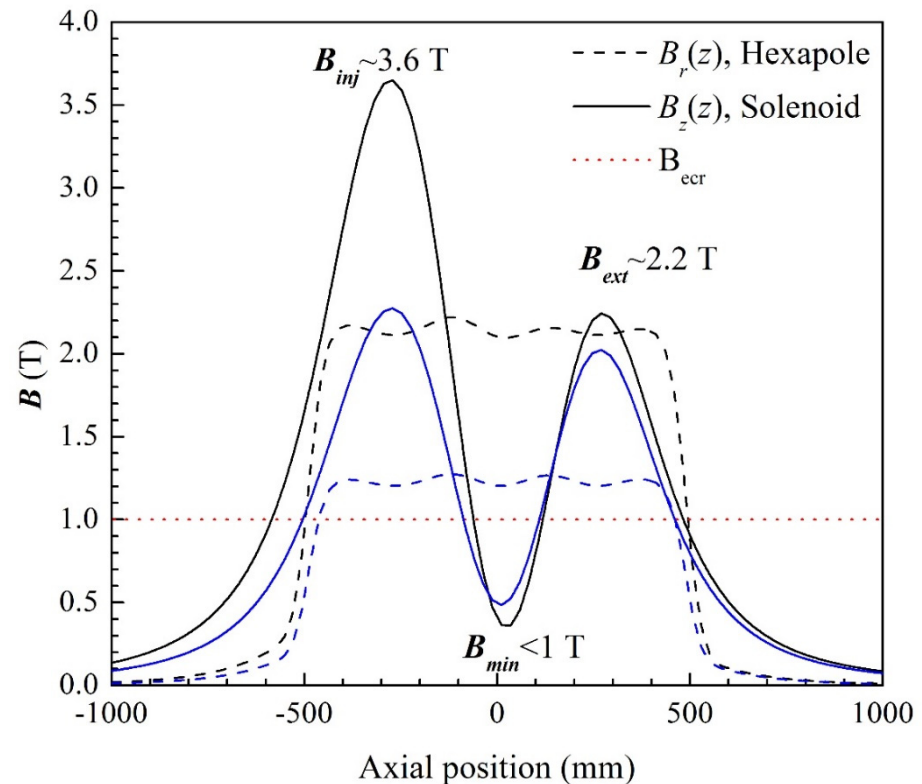
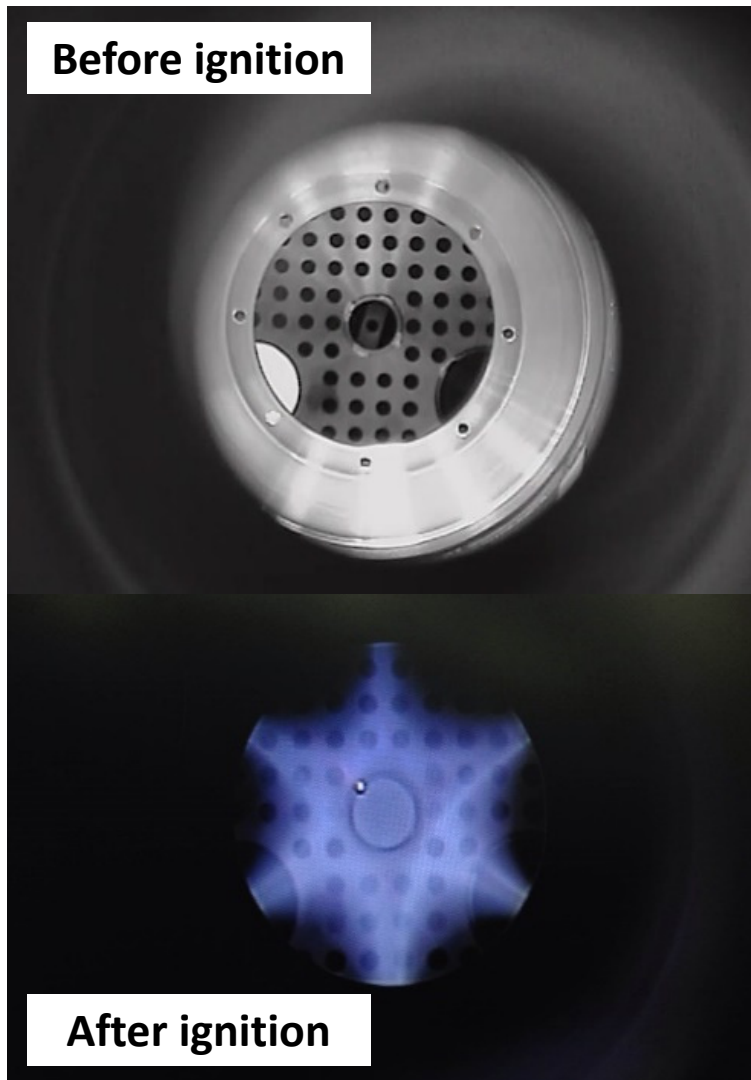
SC magnet monitoring



Beam Diagnostic Program



First plasmas ignition



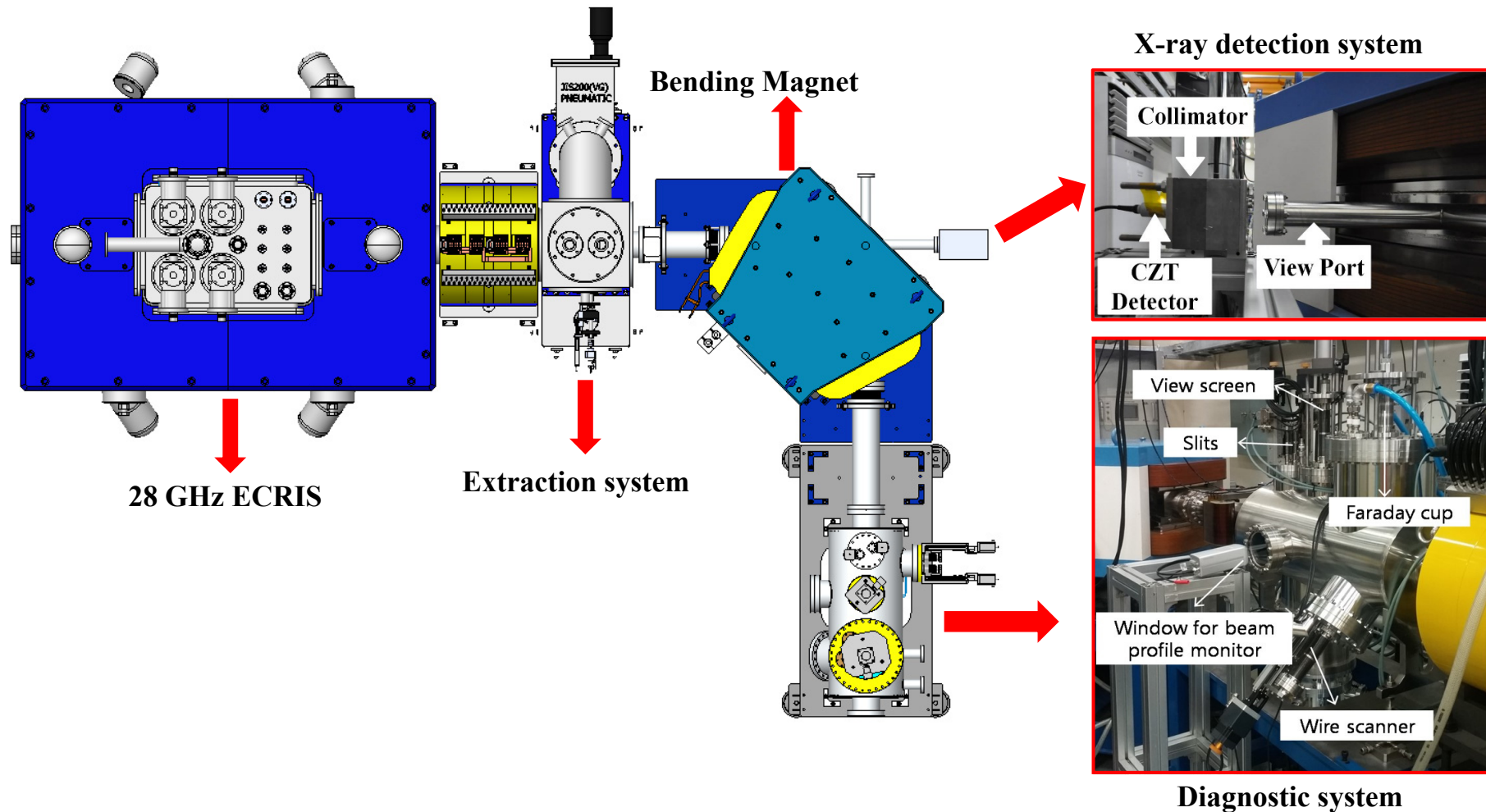
Black lines: Design values,

Blue lines: Plasma ignition condition

✂ Training of superconducting magnet has been much delayed due to LHe shock.

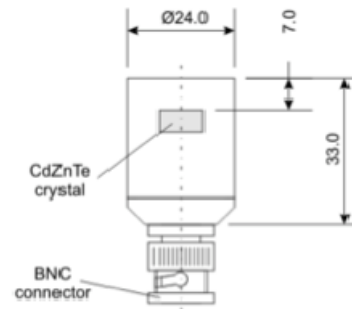
✂ Solenoids performance is now limited by yet-trained Hexapole-magnet.

X-ray and Ion beam measurement system



Calibration of the CZT detector

❖ Specification of the CZT detector



Specification

Detector name	CZT/500 S
Vendor	Ritec Ltd.
Year of fabrication	1998

Basic

Detector type	CdZnTe
Detector geometry	Quasi-hemispherical
Detector sensitive volume	500 mm ³

Bias voltage requirements

Detector high voltage	1000 V
Detector high-voltage polarity	Positive

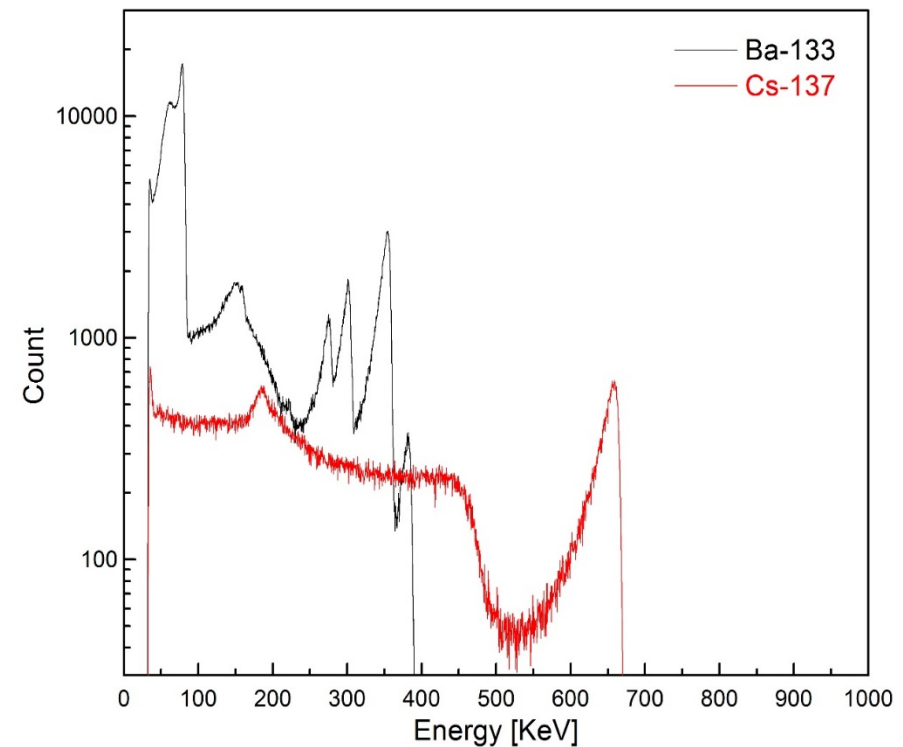
Dimensions

Diameter	23 mm
Length	33 mm
Distance between a top plane of the housing cover and sensitive surface of the detector	7 mm

Connector

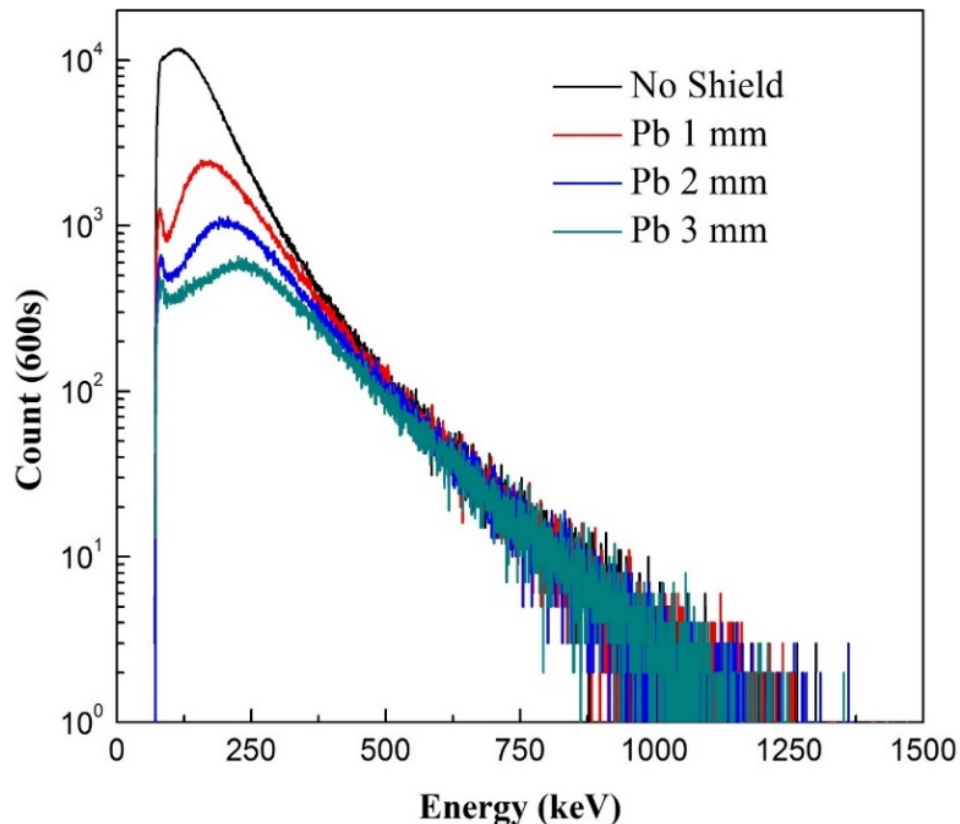
Detector bias voltage	BNC or SHV type
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❖ Calibrated energy distribution



Measured x-ray spectra with respect to the thickness of Pb sheets

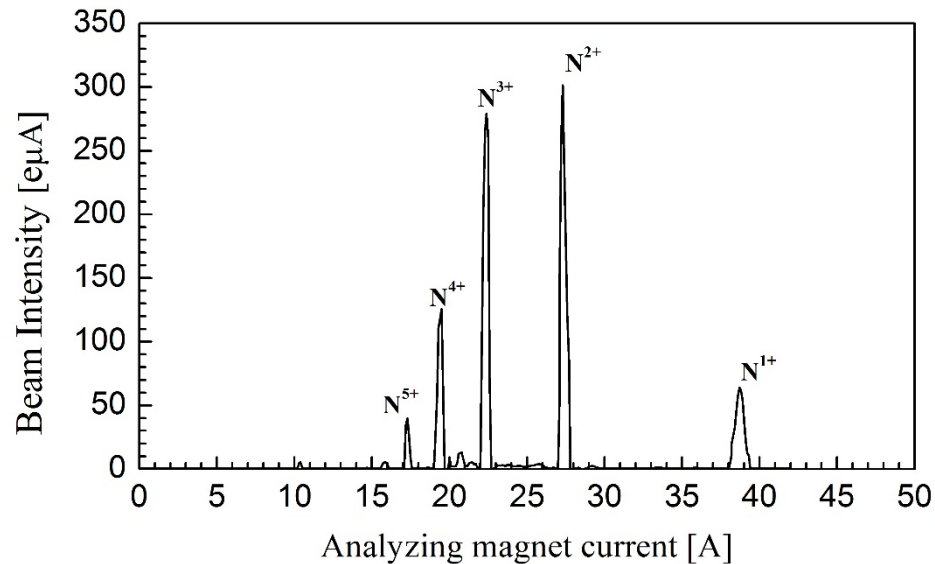
- ◆ a comparison of x-ray energy distribution as a function of the thickness of the lead shielding



Pb Sheet	Shielding rate(<600 keV)
1 mm	60 %
2 mm	75 %
3 mm	82 %

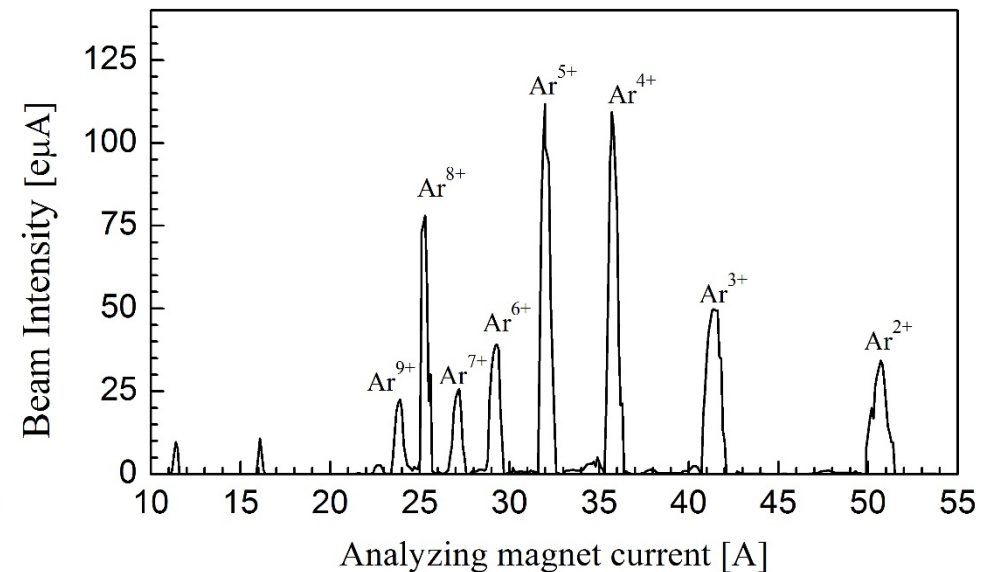
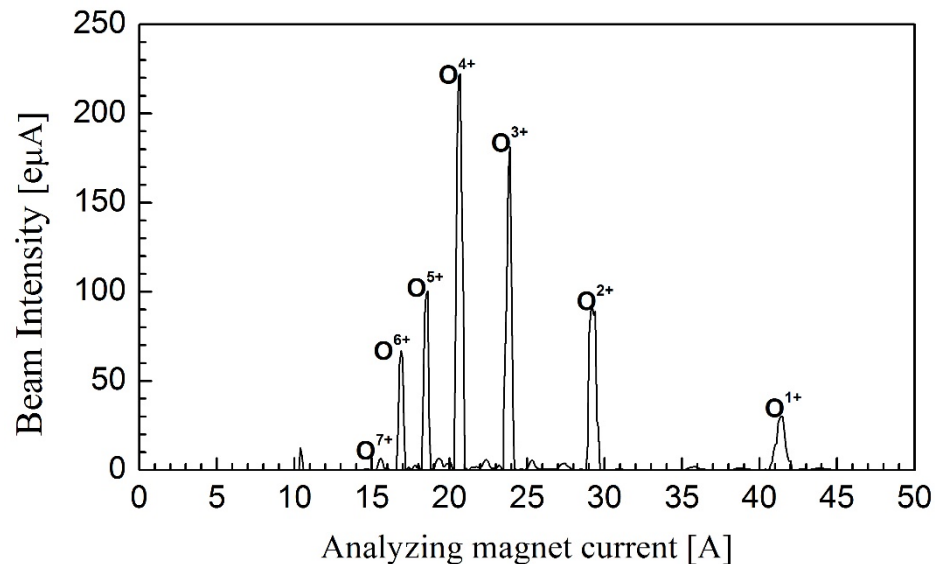
- ◆ The x-ray shielding rate was found to be 80 % for 3 mm thick lead shielding

Ion Beam charge spectra

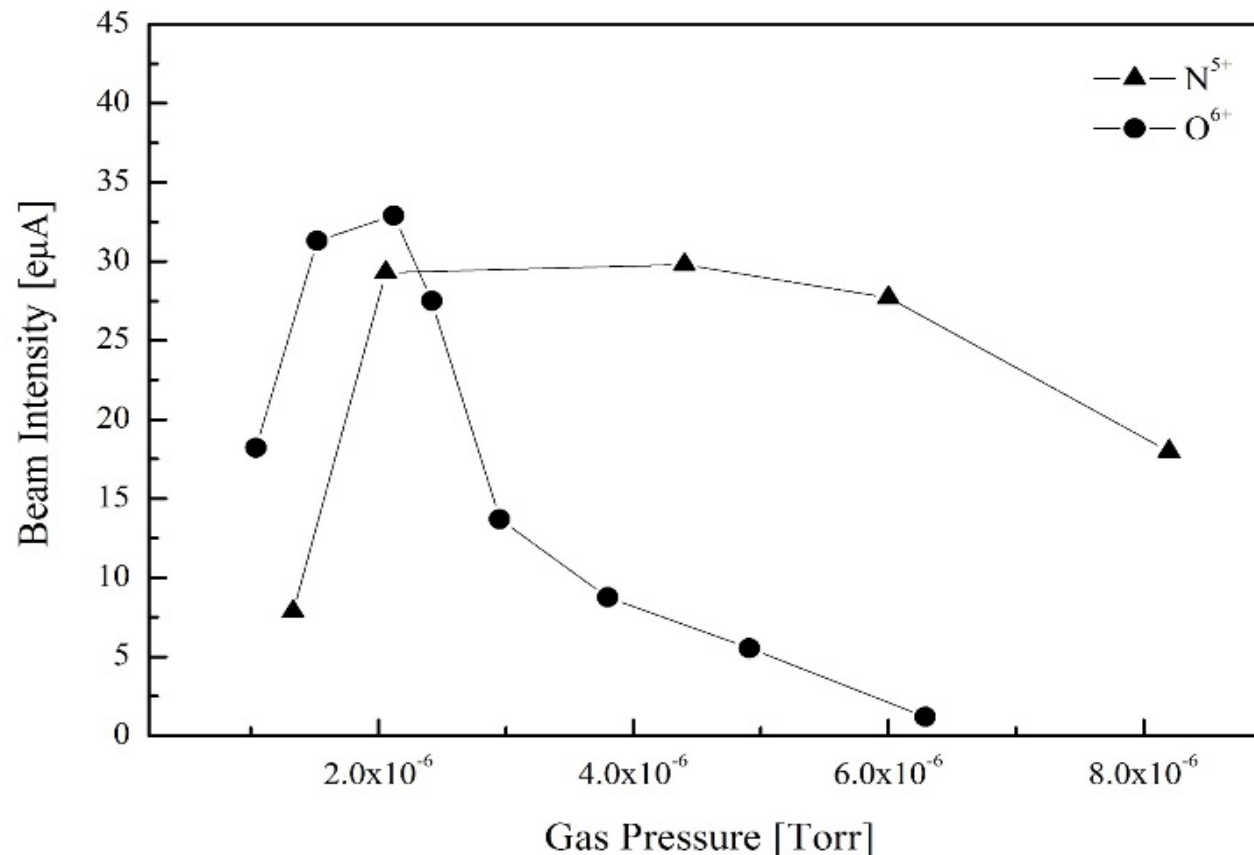


Operation conditions

- Microwave Power = 1 kW
- $B_{inj} = 2.3$ T, $B_r = 1.2$ T, $B_{ext} = 2$ T
- 13 kV (extraction voltage was fixed)

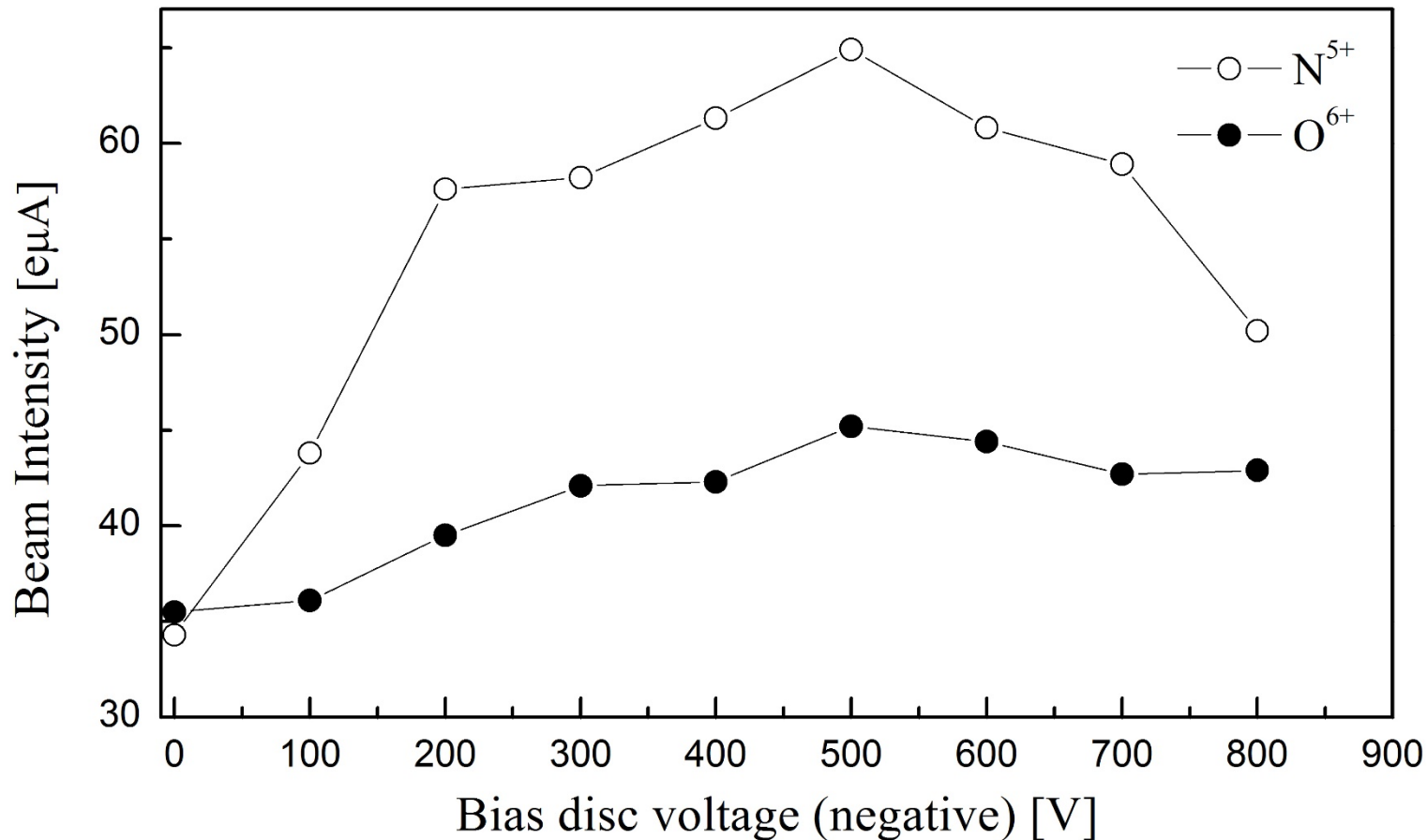


Result as a function of gas pressure



- ◆ The gas pressure represents the vacuum range of plasma chamber at the injection side after supplying the gas.
- ◆ The optimum beam intensities is found when the gas pressure is supplied around 2×10^{-6} Torr.

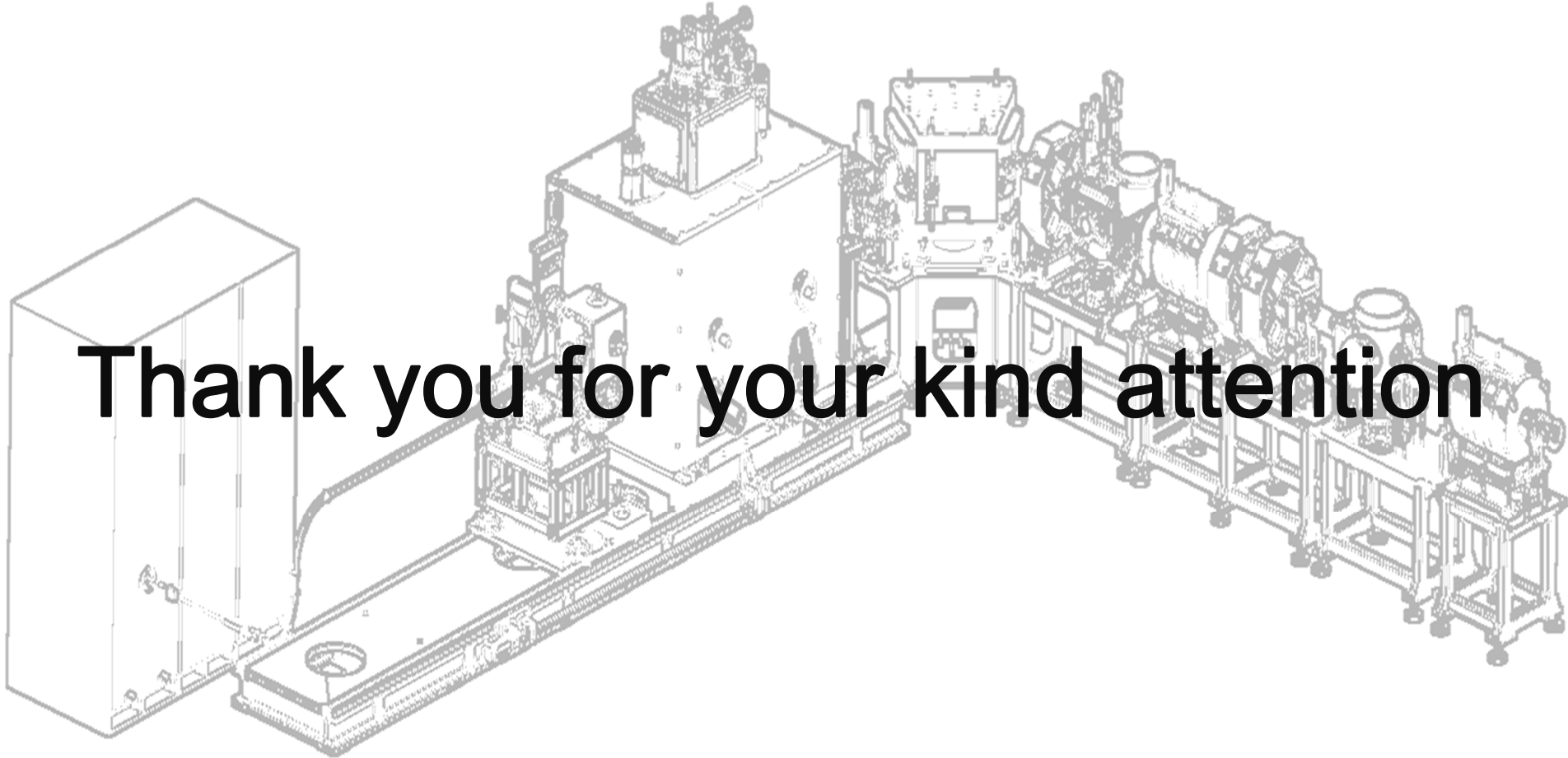
Result as a function of bias disc voltage



- ◆ the beam intensities of N^{5+} and O^{6+} as a function of biased disc voltage (negative)
- ◆ The beam intensities are increased at the voltage about -500 V.

Conclusion & Future Plan

- **We successfully produced charged heavy ions at microwave power 1 kW with 28 GHz microwave.**
- **We measured x-ray spectra from KBSI 28GHz ECR ion source.**
- **We will shield the plasma chamber by use the Pb or Ta sheet, which thickness is more than 2 mm.**
- **The magnetic field must be increased to the design value**
- **We need further improvement of the performance of 28GHz KBSI ECR ion source.**



Thank you for your kind attention